AMENDMENT TRANSMITTAL LETTER (Large Entity) Applicant(s): Wadgi W. Abadeer, eval.					Docket No. Docket No. BUR920000082US1 (13647)	
Application No. 09/811,915	Filing Date JUL March 19-2001	6 2004 Examiner Voith P. Nguye	Customer N 23389	10.	Group Art Unit 2829	Confirmation No. 8953
Invention: A WAFER LEVEL SYSTEM FOR PRODUCING BURN-IN/SCREEN, AND RELIABILITY EVALUATIONS TO BE PREFORMED ON ALL CHIPS SIMULTANEOUSLY WITHOUT ANY WAFER CONTACTING						
COMMISSIONER FOR PATENTS:						
Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.						
CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT	PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT		RATE	ADDITIONAL FEE
TOTAL CLAIMS	50 -	50 =	0	x	\$18.00	\$0.00
INDEP. CLAIMS	2 -	3 =	0	x	\$84.00	\$0.00
Multiple Dependent Claims (check if applicable)						\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$0.00
 No additional fee is required for amendment. □ Please charge Deposit Account No. in the amount of □ A check in the amount of to cover the filing fee is enclosed. ☑ The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 09-0456/IBM ☑ Any additional filing fees required under 37 C.F.R. 1.16. ☑ Any patent application processing fees under 37 CFR 1.17. 						
Leopold Presser Registration No.: Scully, Scott, Mur 400 Garden City I Garden City, New (516) 742-4343	rphy & Presser Plaza	1	Dated: July 1, 20 I certify that this July 1, 2004 class mail under 37 C for Patents, P.O. Box	doc	with the U.S. 1.8 and is address	s being deposited on . Postal Service as first sed to the Commissioner 2313-1450.

cc: LP:jy

Leopold Presser

Typed or Printed Name of Person Mailing Correspondence



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Wadgi W. Abadeer, et al.

Examiner: Vinh P. Nguyen

July 1, 2004

Serial No:

09/811,915

Art Unit: 2829

Filed:

March 19, 2001

Docket:

Dated:

BUR920000082US1 (13647)

For: A WAFER LEVEL SYSTEM FOR

PRODUCING BURN-IN/SCREEN. AND RELIABILITY EVALUATIONS TO BE PERFORMED ON ALL CHIPS SIMULTANEOUSLY WITHOUT ANY

WAFER CONTACTING

Confirmation No.: 8953

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. 1.111

Sir:

In response to the Office Action of April 8, 2004, applicants respectfully request that the following amendments be entered into this application:

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Dated: <u>July 1, 2004</u>